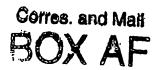
Appl. No. 10/027,935 Amdt. dated August 31, 2005 Reply to Office Action of June 3, 2005





## RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE\ **EXAMINING GROUP**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Gerard S. MOLONEY

Serial No. 10/027,935

Filed: December 21, 2001

For: APPARATUS AND METHOD

FOR CHEMICAL-MECHANICAL

POLISHING (CMP) HEAD

HAVING DIRECT PNEUMATIC WAFER POLISHING PRESSURE

Group Art Unit: 3724

Examiner: ELEY, Timothy V.

Confirmation No.: 2631

**CERTIFICATE OF MAILING** 

I hereby certify that this correspondence and its listed enclosures is being deposited with the United States Postal Service as First Class Mail addressed to Commissioner for Patents; P.O. Box 1450; Alexandria, VA

22313-1450 on August

Signed

## <u>AMENDMENT</u>

MAIL STOP AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

This Amendment is in response to the final Office Action mailed on June 3, 2005. Please amend the application as indicated below.

Amendments to the claims are reflected in the listing of claims which begins at page 3 of this paper.

Remarks/Arguments begin on page 7 of this paper.